



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/664,744
Filing Date September 18, 2003
Inventor Michael T. Andreas
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Fernando L. Toledo
Attorney's Docket No. MI22-2335
Title: Method of Polishing a Semiconductor Substrate, Post-CMP Cleaning
Process, and Method of Cleaning Residue from Registration Alignment Markings

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

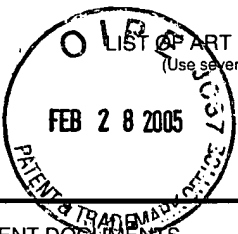
References - See Attached Form PTO-1449


In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the patents listed on the attached Form PTO-1449. No admission is made regarding whether the submitted reference is prior art.

Respectfully submitted,

Dated: 2-28-05

By 
Mark S. Matkin
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2335		SERIAL NO. 10/664,744		
 <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT: Michael T. Andreas				
				FILING DATE September 18, 2003		GROUP 2323		
U.S. PATENT DOCUMENTS								
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,835,668	12/2004	Andreas et al.	438	745		
	AB	6,835,121	12/2004	Andreas	451	41		
	AC	6,787,473	09/2004	Andreas	438	692		
	AD	6,635,562	10/2003	Andreas	438	633		
	AE	6,627,550	09/2003	Andreas	438	691		
	AF	6,589,882	07/2003	Andreas et al.	438	745		
	AG	6,468,951	10/2002	Grieger et al.	510	175		
	AH	6,375,548	04/2002	Andreas	451	41		
	AI	6,358,325	03/2002	Andreas	134	2		
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
EXAMINER		DATE CONSIDERED						
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								

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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) <div style="text-align: center; margin-top: 20px;">  </div>				APPLICANT: Michael T. Andreas			
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U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,273,100	08/2001	Andreas et al.	134	1.3	
	AB	6,269,511	08/2001	Andreas et al.	15	77	
	AC	6,265,781	07/2001	Andreas	257	765	
	AD	6,044,851	04/2000	Grieger et al.	134	1.3	
	AE	5,855,811	01/1999	Grieger et al.	252	79.3	
	AF	2003/0143857	07/2003	Andreas	438	710	
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AJ						
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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	AN						
	AO						
EXAMINER		DATE CONSIDERED					
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